



Laser Simulation of Single Event Effects in Pulse Width Modulators and Memories

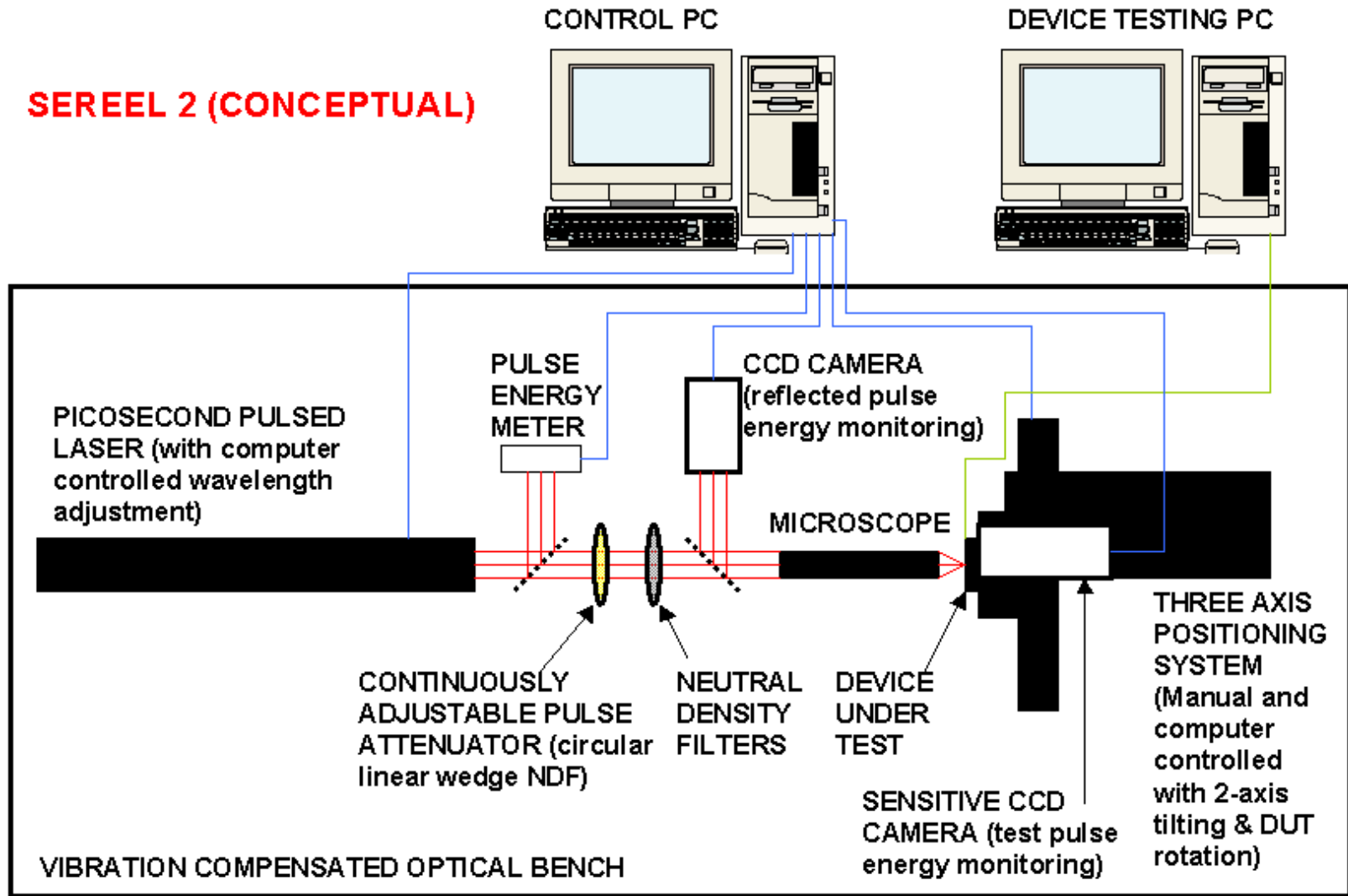
Final Presentation of ESA/ESTEC Contract No.
16916/02/NL/PA (Phase 2)

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- Second phase of an ongoing laser SEE research collaboration with the European Space Agency
 - Utilising MBDA's Single Event Radiation Effects in Electronics Laser (SEREEL)
- Principal research topics
 - Laser Memory Mapping
 - Laser SEE sensitivity profiling using multi-wavelength testing
 - Laser SEE testing of complex devices: Pulse Width Modulators
- In parallel: design and implementation of a second generation laser SEE test facility known as SEREEL2

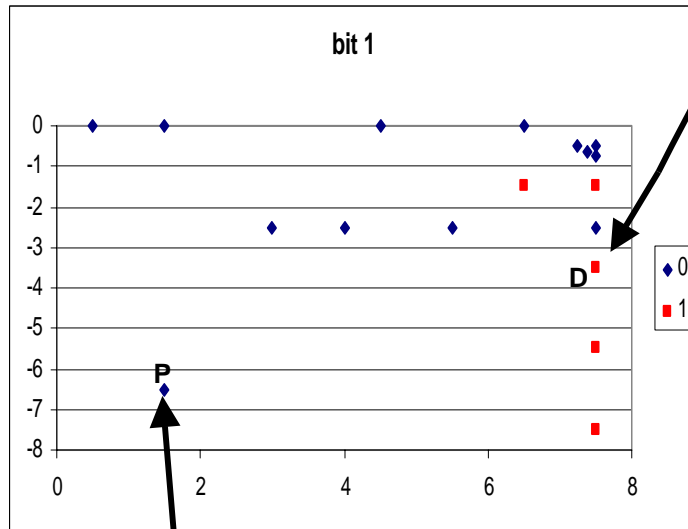
The principles of laser SEE testing

SEREEL 2 (CONCEPTUAL)

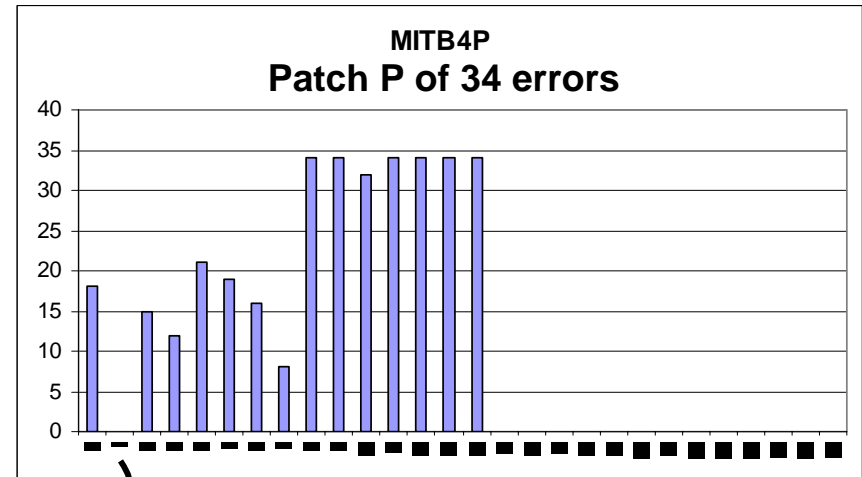
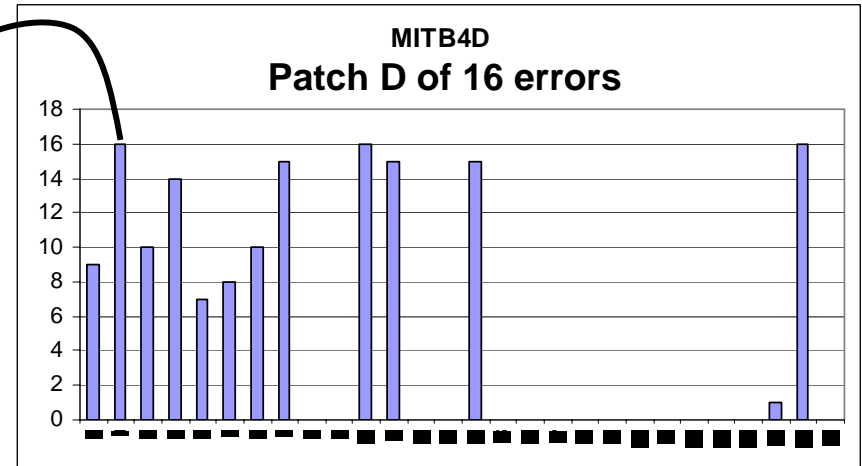


Laser Memory Mapping - Error Patch Approach

Bit 1 values in plotted error patches

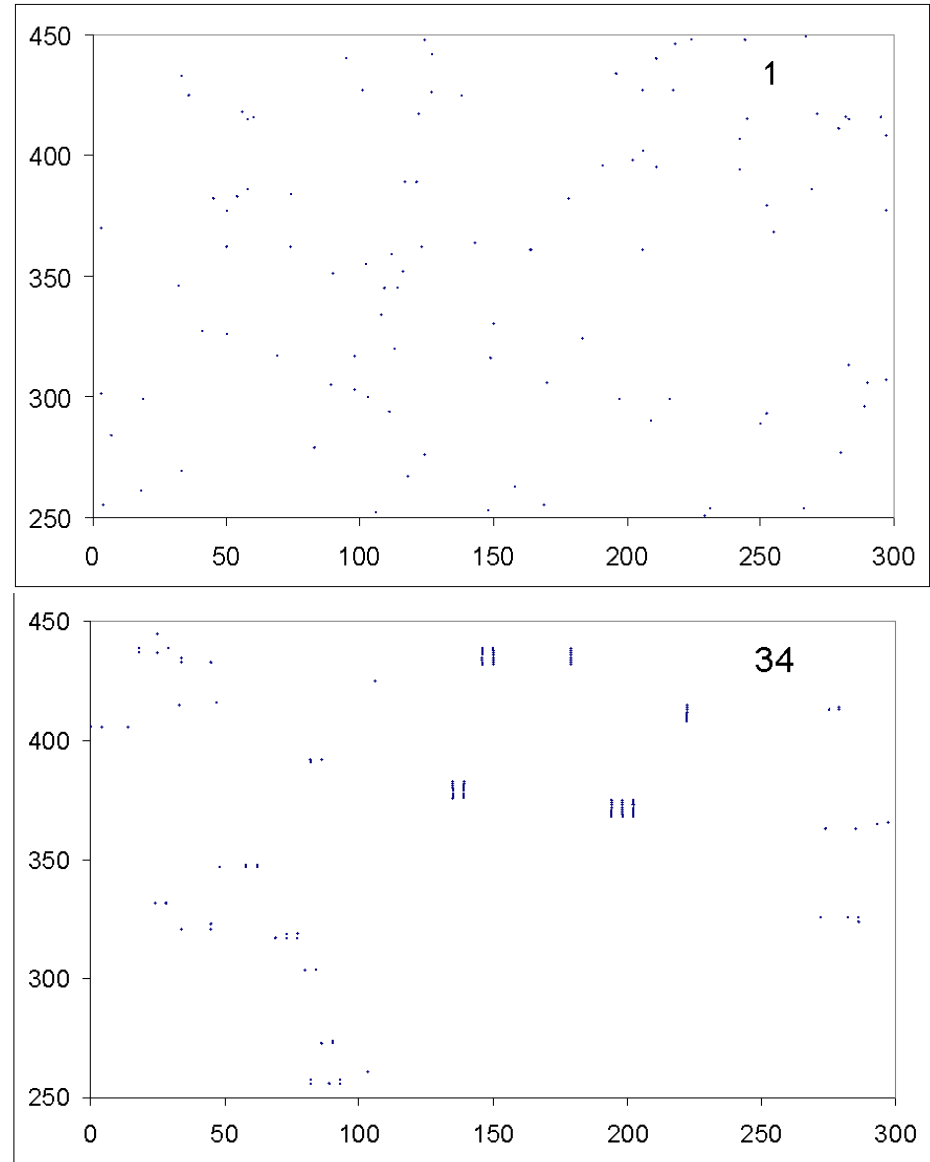


Address bit sums in error patches

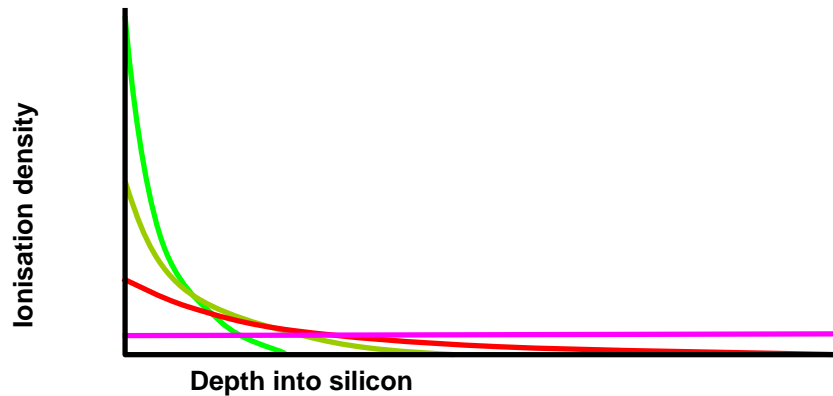


Using laser map to plot ion beam upsets in the Cypress CY7C109

- Using the laser-derived maps to plot previously captured ion beam upsets in a 1Mbit CY7C109 showed previously invisible spatial clustering indicative of MBU's
- The clustering was not present at 1MeV cm²/mg, but increased with LET and became very marked at 34 MeV cm²/mg
- The figures show upsets plotted over the same sub-section of the die at 1 and 34 MeV cm²/mg for the CY7C109

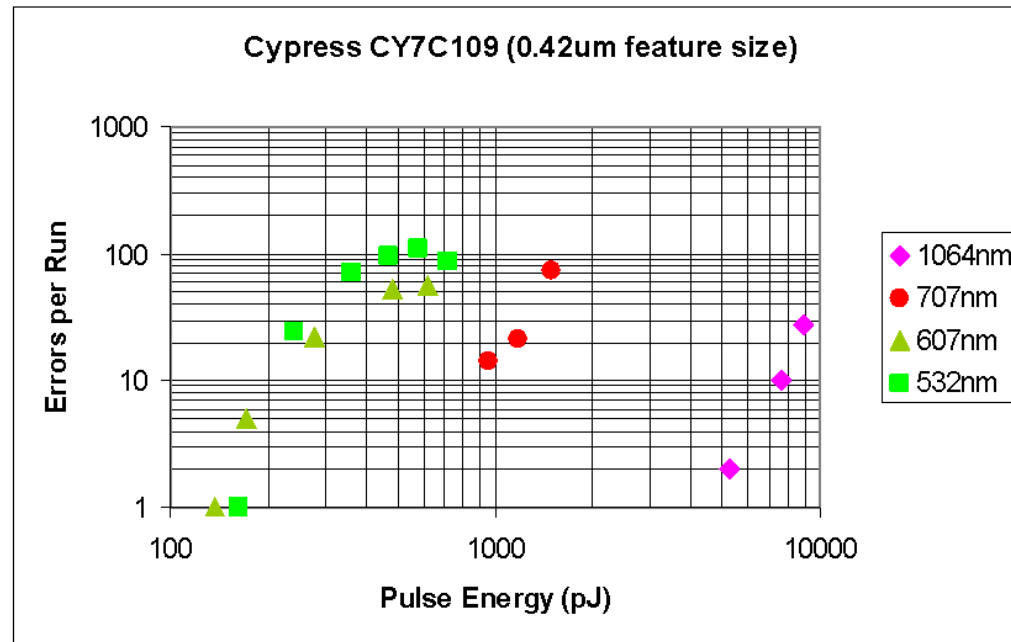


SEE Sensitivity Profiling – Variation with Depth



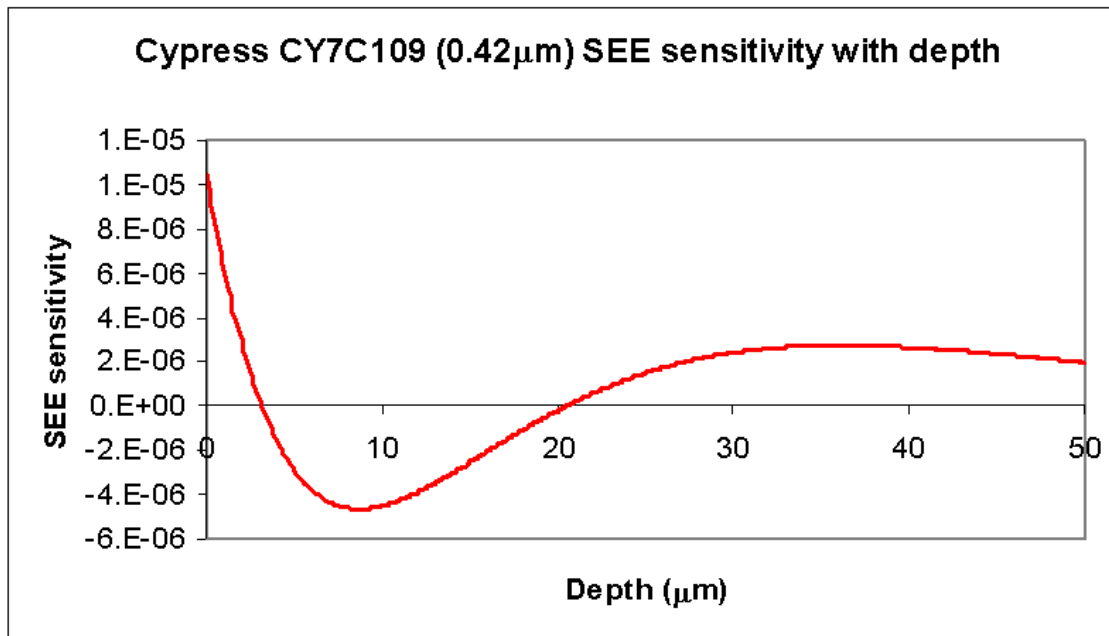
$$\frac{Q_{crit}}{E_{abs}(f(\lambda))f(\lambda)} = \int_0^{\infty} sens(x) \exp(-f(\lambda)x) dx$$

See “Probing the Charge Collection Sensitivity...” IEEE Trans Nuc Sci, pp.2969-2976, Dec 2002 for details

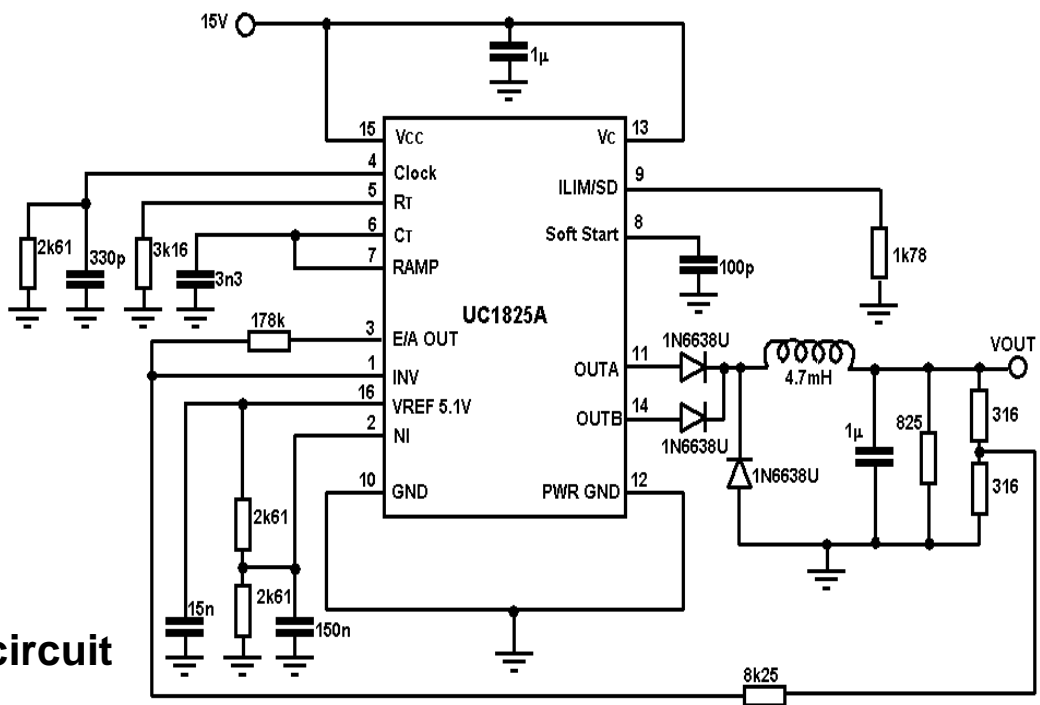


Example of the sensitivity profile derived for the Cypress CY7C109

- The approach often gives a profile that changes sign at different depths
 - The interpretation is that ionisation may cause charge to flow on or off a memory cell node depending on its location relative to the node
- The sensitivity profile seems to range deep into the silicon due to the relatively high sensitivity to infrared
 - This seems to be a laser version of the charge funnelling effect seen with ions

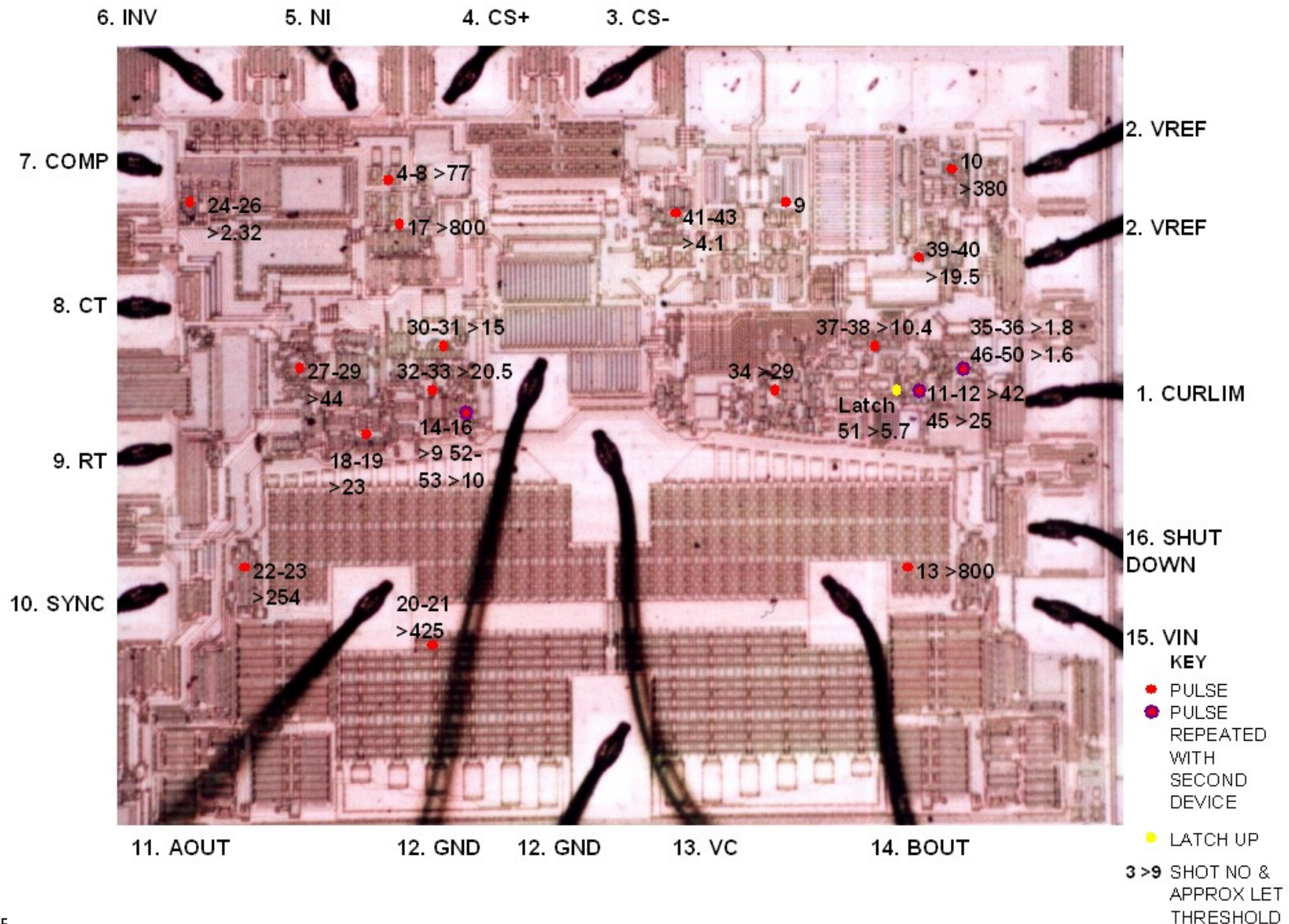


UCC1806 PWM test circuit



UC1825A PWM test circuit

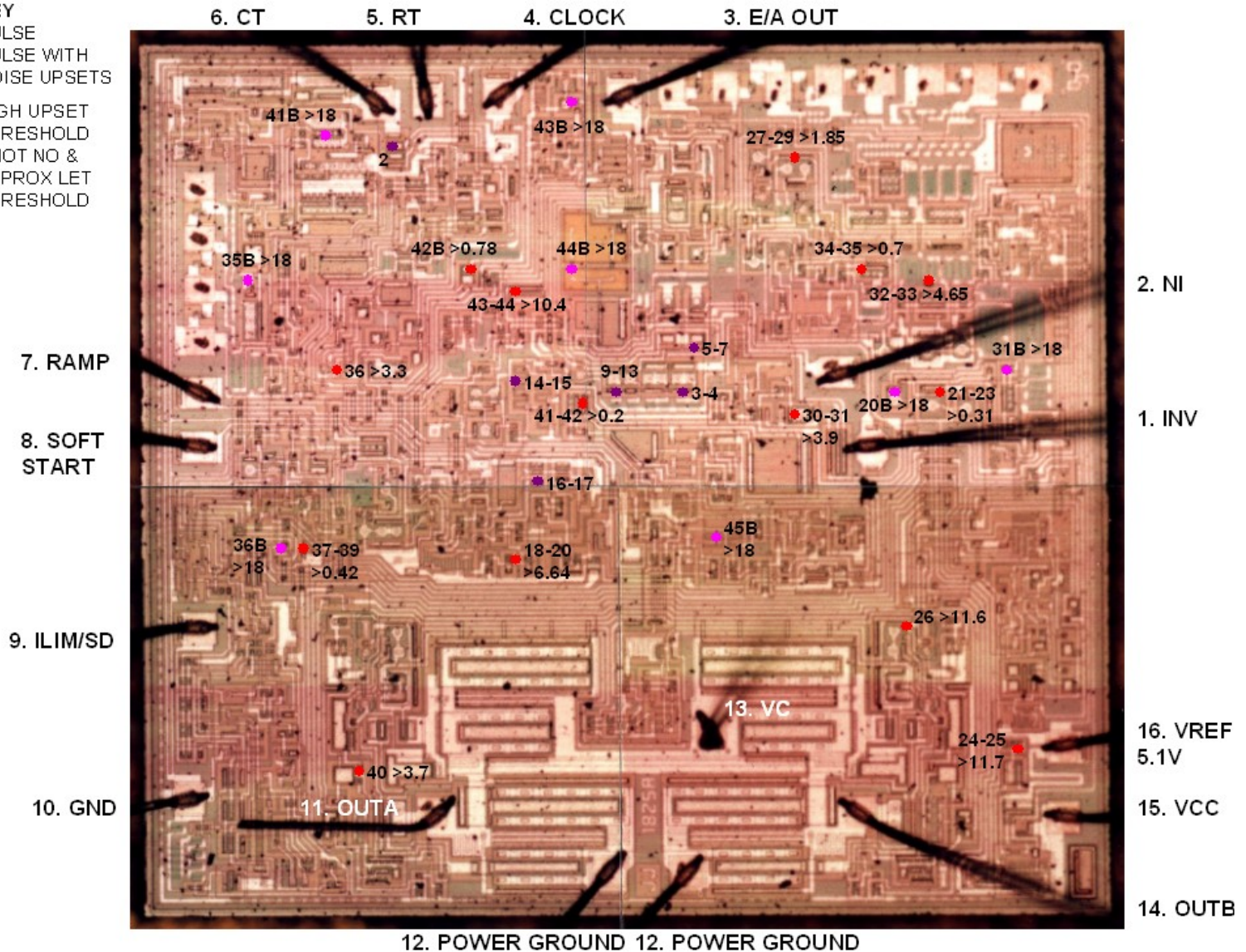
Laser test pulse locations for the UCC1806 (thresholds in MeVcm²/mg)



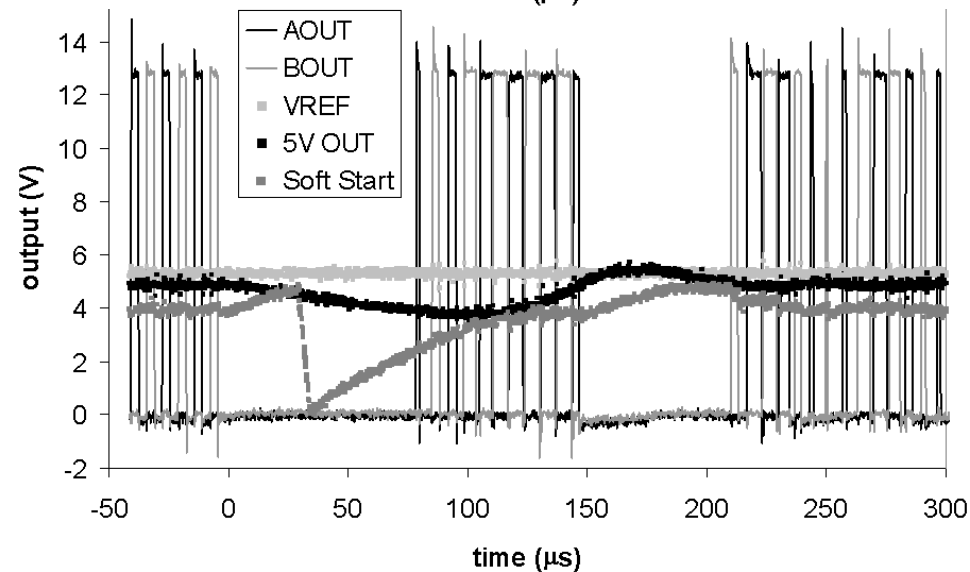
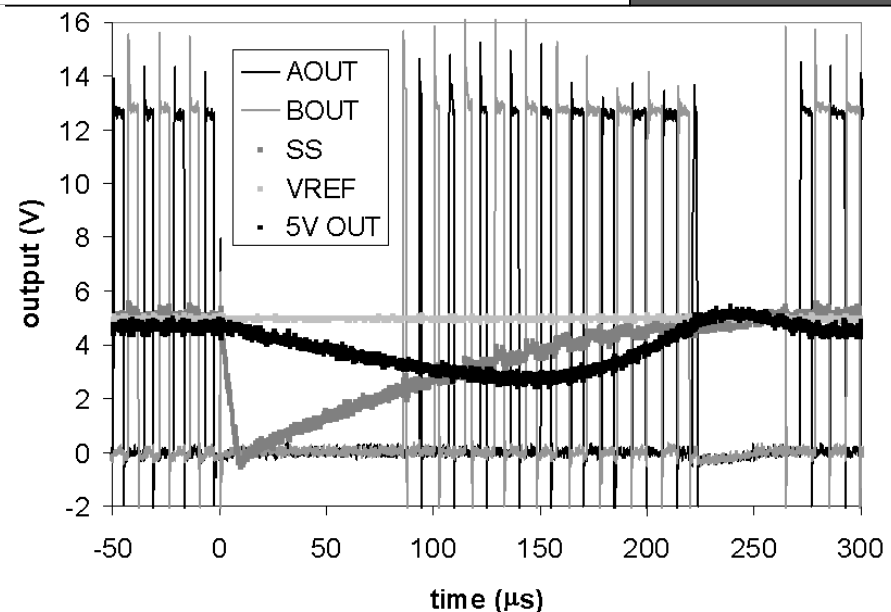
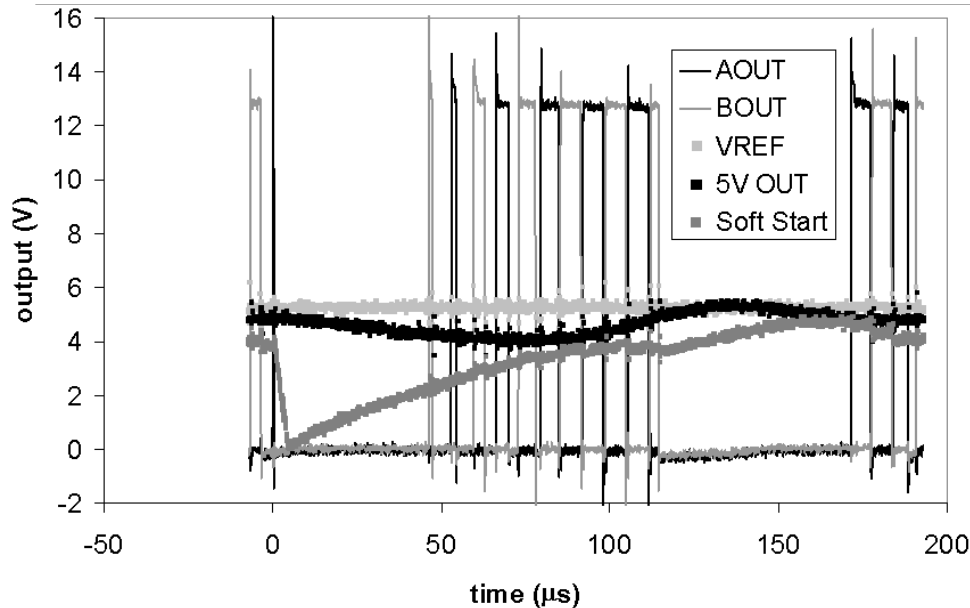
Ref. D/TE

Laser test pulse locations for the UC1825A (thresholds in MeVcm²/mg)

- KEY**
- PULSE
 - PULSE WITH NOISE UPSETS
 - HIGH UPSET THRESHOLD
- 3 > 9 SHOT NO & APPROX LET THRESHOLD



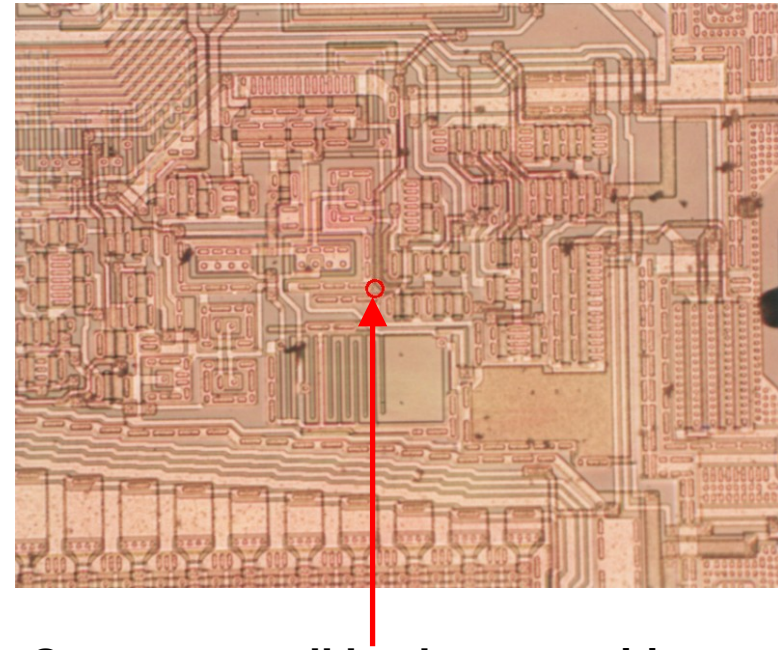
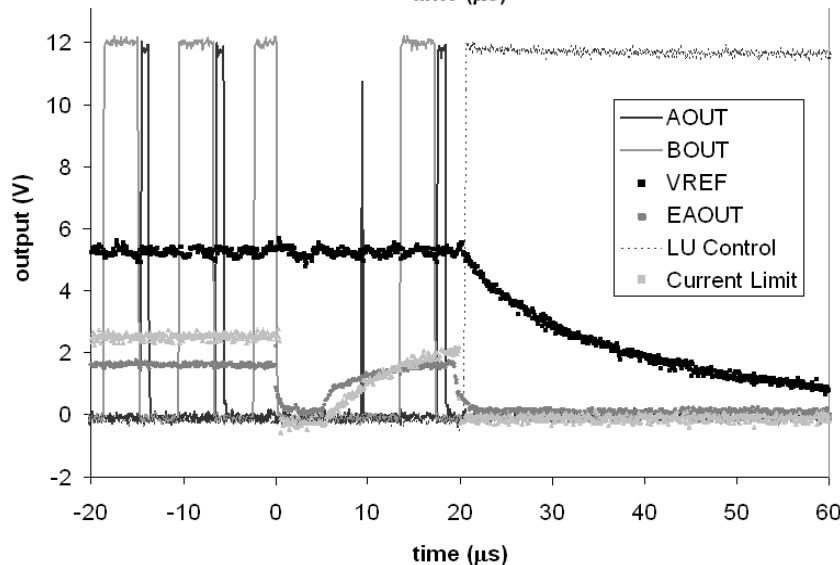
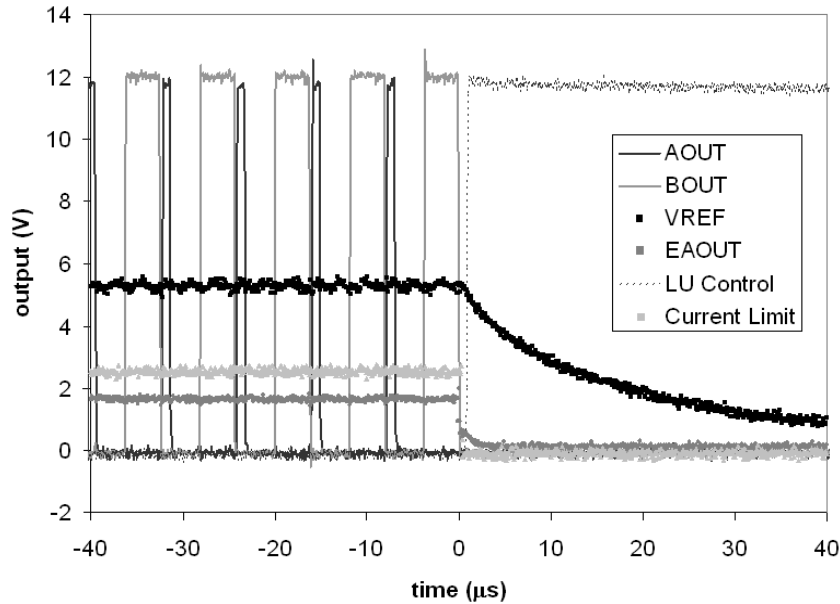
Matching laser and ion SET's in the UC1825A



The ion induced SET (above) matches the laser induced SET (top left) located in the error amplifier circuitry, rather than the laser induced SET (bottom left) located in the soft start circuitry

➡ Ion strike probably hit the error amplifier

Laser induced latch-up & delayed latch-up in the UCC1806



One very small latch-up sensitive location was found using the SEE laser.

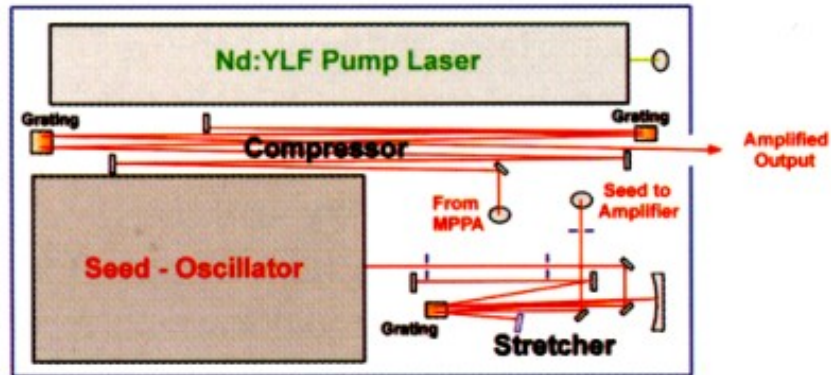
At large laser pulse energies, latch-up was immediate, but, near the threshold laser pulse energy, latch-up was typically delayed to tens of microseconds after upset

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- NSREC
2005
Seattle

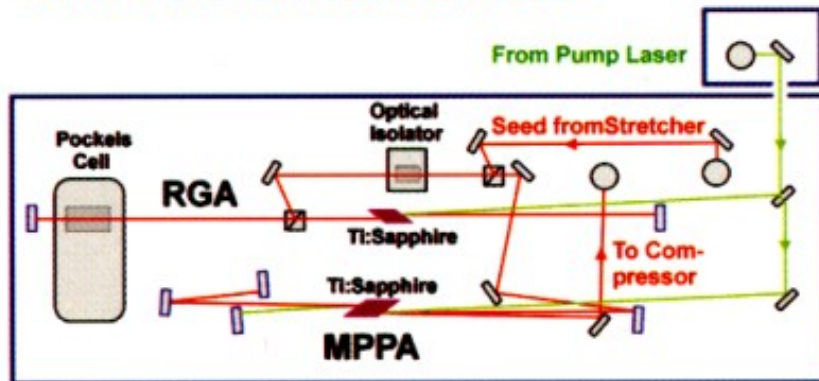


New laser system for the Single Event Radiation Effects in Electronics Laser (SEREEL) facility – SEREEL2

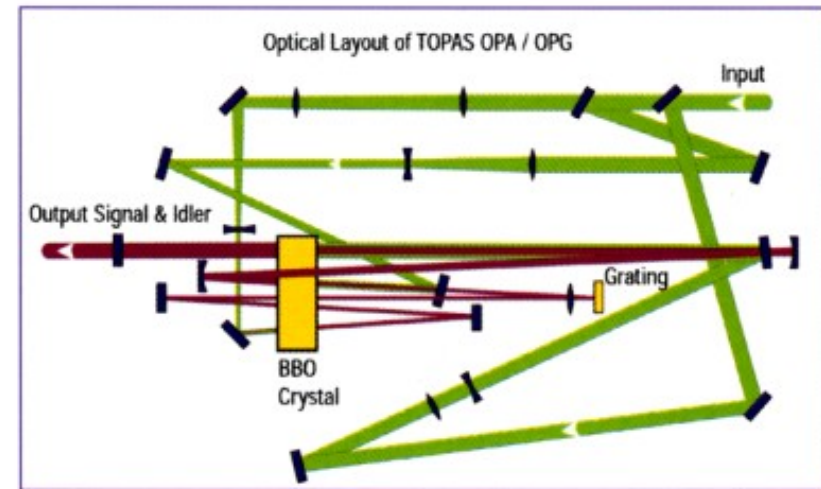
INTEGRA LAYOUT LOWER LEVEL



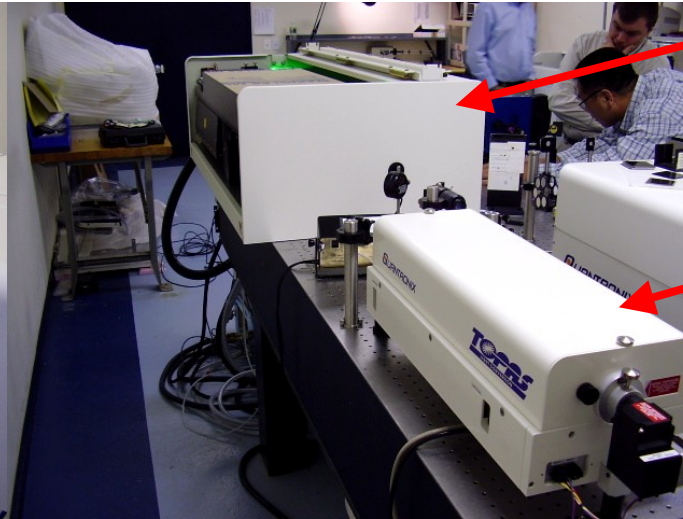
INTEGRA LAYOUT UPPER LEVEL



TOPAS OPTICAL LAYOUT

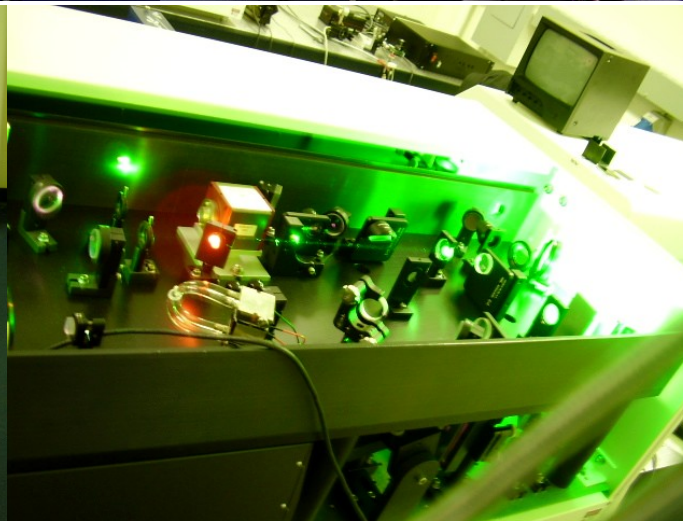
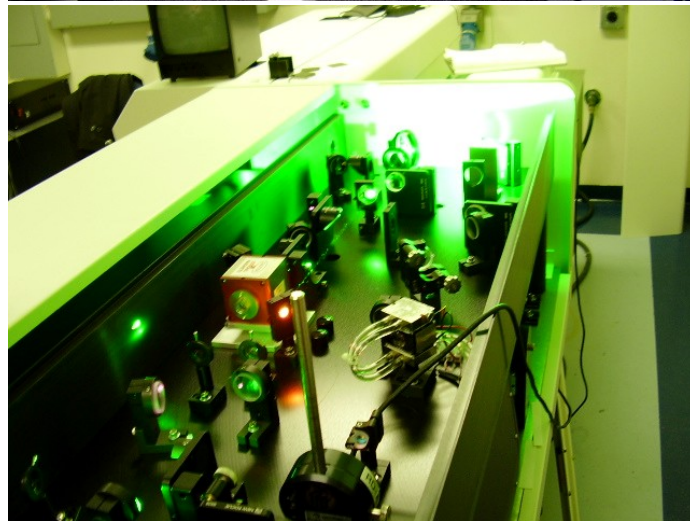


SEREEL2 Laser Commissioning at Quantronix in New York in April 2005

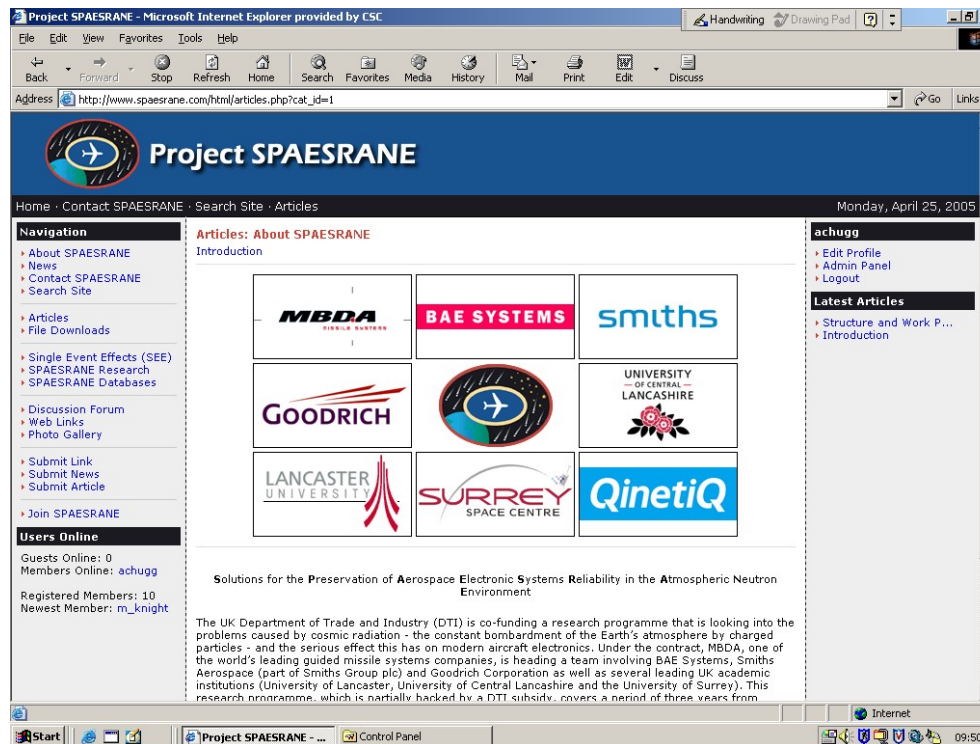


INTEGRA
Pump and
seed laser

TOPAS
Optical
Parametric
Amplifier



- More details of SEREEL and updates on the imminent commissioning of SEREEL2 may be found on the SPAESRANE website
 - <http://www.spaesrane.com/>
- SPAESRANE is the UK research consortium for Solutions for the Preservation of Aerospace Electronic Systems Reliability in the Atmospheric Neutron Environment



- New techniques for laser mapping of memories developed
 - Rich menagerie of MBU's seen at high LET on mapping old ion beam data
- Laser depth profiling of SEE sensitivity demonstrated
 - Ionisation at different depths causes different direction of charge flow relative to nodes
 - Longer wavelengths (infrared) penetrate the silicon to produce funnelling of charge from the substrate
- Laser SEE testing of PWM's
 - Can infer locations of ion upsets on the dies through correlations with laser induced SEE
 - Laser testing showed delayed onset of SEL near the threshold
- Second generation laser SEE facility (SEREEL2) to be installed at MBDA in June